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PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Hiromichi Watanabe, et al.
Application No. : 10/723,349
Filed : November 25, 2003
Title : SUBSTRATE FOR CIRCUIT WIRING

Grp./Div. : N/A
Examiner : N/A

Docket No. : 51580/DBP/A400

STATUS INQUIRY

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Post Office Box 7068
Pasadena, CA 91109-7068
April 21, 2004

Commissioner:

This is to inquire as to the status of the above-identified patent application. I would appreciate a reply at your earliest convenience.

Respectfully submitted,
CHRISTIE, PARKER & HALE, LLP

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By D. Bruce Prout
D. Bruce Prout
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